

PATENT

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IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicants: Kim et al.

Serial No.: 10/032,687

Filed: December 28, 2001


For: METHOD OF FORMING  
WIRING IN SEMICONDUCTOR  
DEVICES

Group Art Unit: 2822

Examiner: Maria F. Guerrero

I hereby certify that this paper is being  
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August 29, 2003

  
James P. Zeller  
Reg. No. 28,491

PETITION UNDER 37 C.F.R. §1.136(a)

Commissioner for Patents  
Washington, DC 20231

Sir:

Applicants, by their attorneys, petition for a two-month extension of time to file a  
response to the official action of April 3, 2003.


Submitted herewith is the patent application processing fee of \$410.00.

Any additional required fee may be charged or any overpayment credited, to our  
Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

By:

  
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July 29, 2003

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